Tool ID: 320 Tool Location: 114

#### **Equipment Information Sheet**

## **Angstrom E-Beam Evaporator**

Manager: Aaron Windsor 607-254-4831 Backup: Christopher Alpha 607-254-4913

Calls to staff phones will be automatically forwarded to their cell phones during accessible hours. At other times

leave a message or send them an email.

#### **SAFETY**

#### **USAGE RESTRICTIONS**

• Must remain in cleanroom when electron beam is on.

# SCHEDULING/SIGN-UP RESTRICTIONS MATERIALS COMPATIBILITY CATEGORY

Minimum Tool Time: 30 minutes

### Tool Category 3: Silcion, III-V Compound Semiconductor, Glass and Metal Category

Allowed	Not Allowed
Tool category 1/1E and 2 materials	Glass Substrates
III/V compound Semiconductors allowed	No CNF Class A or Class B metals-and oxides/compounds of i.e. (Magnesium, Zinc, Barium, Calcium)
PECVD and ALD Films	No High Vapor pressure materials
Cured organics and baked Photoresist	
Organic/Bio Materials prepped w/o Salt Buffers	

High Vapor Pressure Metals and Compounds are materials that have a vapor pressure above 1e-6 Torr at  $400\ C$ .

**Additional Material Restrictions and Exceptions** 

Last Updated: 09/06/2022